

April 20 (Tue.)				April 21 (Wed.)			
PDT UTC-7	CEST UTC+2	JST UTC+9	Digital Forum	PDT UTC-7	CEST UTC+2	JST UTC+9	Digital Forum
19-Apr 16:00	20-Apr 1:00	8:00 - 8:10	Opening	20-Apr 16:00	21-Apr 1:00	8:00 - 9:40	Session 7 Opening Session: Day 2
		8:10 - 9:30	Session 1 Opening Session: Day 1				
17:30	2:30	Keynote Dr. Klaus Schuegraf (Intel Corporation) Invited Talk Dr. Yu Cao (Hermes Microvision, Inc., an ASML company)				Invited Talk Mr. Aki Fujimura (D2S) Dr. Stuart Sherwin (University of California, Berkeley)	
		9:30 - 9:50	Break			9:40 - 10:00	PMJ Entertaining Movie 2 / Break
17:50	2:50	9:50 - 10:50	Session 2 ML & MPC	18:00	3:00	10:00 - 12:20	Session 8 NIL
						Invited Talk Dr. Douglas Resnick (Canon Nanotechnologies, Inc.) Dr. Sung-won Youn (AIST)	
18:50	3:50						
		10:50 - 11:10	PMJ Entertaining Movie 1 / Break				
19:10	4:10	11:10 - 12:20	Session 3 EUV from Asia 1	20:20	5:20		
		Invited Talk Prof. Takeo Watanabe (University of Hyogo)				12:20 - 13:50	Lunch Break
20:20	5:20						
		12:20 - 13:50	Lunch Break				
21:50	6:50	13:50 - 14:30	Session 4 Lithography	21:50	6:50	13:50 - 15:00	Session 9 EUV from Asia 2
						Invited Talk Prof. Takahiro Kozawa (Osaka University)	
22:30	7:30			23:00	8:00		
		14:30 - 14:50	PMJ Entertaining Quiz / Break			15:00 - 15:20	Break
22:50	7:50	14:50 - 15:50	Session 5 PSM, Etching & FPD				
				23:20	8:20	15:20 - 16:50	Session 10 Inspection
23:50	8:50					Invited Talk Mr. Hiroki Miyai (Lasertec Corporation)	
		15:50 - 16:10	PMJ Entertaining Movie 2 / Break	21-Apr 0:50	9:50		
20-Apr						16:50 - 17:10	PMJ Entertaining Movie 1 / Break
0:10	9:10	16:10 - 18:00	Session 6 EUV from Europe				
		Invited Talk Dr. Bartosz Bilski (Carl Zeiss SMT GmbH) Dr. Jan van Schoot (ASML Netherlands B.V.) Dr. Emily Gallagher (IMEC)		1:10	10:10	17:10 - 18:50	Session 11 Writing & CD Analysis
2:00	11:00						
				3:00	12:00	18:50 - 19:00	Closing

*Poster presentations will be available from April 20th (JST).

PMJ movies and Sakura movie will be provided during break time.

